

Notice of References Cited

Application/Control No.

10/596,755

Applicant(s)/Patent Under

Reexamination

OKAMOTO ET AL.

Examiner

HUI CHIN

Art Unit

4131

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,350,807	02-2002	Blok et al.	524/493
	B	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

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	U	Translation of JP56109205, August, 1981.
	V	Translation of JP 2000044633, February, 2000.
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	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a))
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